

| Ref # | Hits    | Search Query   | DBs   | Default Operator | Plurals | Time Stamp       |
|-------|---------|--|---|------------------|---------|------------------|
| L1    | 63168   | (wafer or substrate or semiconductor) near3 (rotate or rotated or rotating or rotation or revolve or revolved or revolving or spin or spinned or spinning) | US-PGPUB;<br>USPAT;<br>USOCR;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR               | ON      | 2004/12/01 15:48 |
| L2    | 1591700 | (liquid or solution or fluid or electrolyte or water) near3 (flow\$5 or direct\$5 or suppl\$5 or pump\$5 or inlet or pass\$5)                              | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB           | OR               | ON      | 2004/12/01 15:52 |
| L3    | 13741   | I1 and I2  | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB           | OR               | ON      | 2004/12/01 15:52 |
| L4    | 2848    | I3 and (electroplat\$8 or electroly\$8 or electrodeposit\$8 or electrochem\$8)   | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB           | OR               | ON      | 2004/12/01 15:53 |
| L5    | 2222    | I4 and semiconductor   | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB           | OR               | ON      | 2004/12/01 15:53 |
| L6    | 133     | I5 and (cathode near3 (ring or annular or circular or clamp or periph\$5))   | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB           | OR               | ON      | 2004/12/01 15:57 |
| L7    | 127     | I6 and anode   | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB           | OR               | ON      | 2004/12/01 15:57 |